Docket No.: 060188-0768

PATENT

IFW

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Response Under 37 CFR 1.116 - Expedited Procedure

Customer Number: 20277

Kenji YONEDA

Confirmation Number: 9901

Application No.: 10/774,522

Group Art Unit: 2891

Filed: February 10, 2004

Examiner: SARKAR, Asok K.

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

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Transmitted herewith is an Amendment in the above-identified application.

MAR 0 1 2006

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	23	23	0	\$50.00 =	\$0.00
Independent Claims	5	5	0	\$200.00 =	\$0.00
		Multiple dependent claims newly presented			\$0.00
	Fee for extension o	Fee for extension of time			
					\$0.00
		Total of Above Calculations			\$0.00

Please charge my Deposit Account No. <u>500417</u> in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty Registration No. 36,139

Please recognize our Customer No. 20277 as our correspondence address.

Phone: 202.756.8000 MEF:jrj Facsimile: 202.756.8087 Date: March 1, 2006

600 13th Street, N.W.

Washington, DC 20005-3096

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DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 1, 2005, having a three-month shortened statutory period for reply set to expire on March 1, 2006, please amend the above identified patent application as follows.